



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#8 17-
7/29/03
RECEIVED
JUL 22 2003
GROUP 1700

Applicant(s): Small et al.
Assignee: EKC Technology, Inc.
Title: Catalytic Composition for Chemical-Mechanical Polishing, Method of Using Same, and Substrate Treated with Same
Application No.: 10/074,757 Filing Date: February 11, 2002
Examiner: Marcheschi, Michael A. Group Art Unit: 1755
Docket No.: CHEM.004US0 Conf. No.: 9276

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 7/14/03

Eileen Bower
Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicants respectfully petition for a three-month extension of time within which to respond to the January 15, 2003 outstanding Office Action, such extension allowing the undersigned until July 15, 2003 to respond.

07/17/2003 CCHAU1
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930.00 OP

CHEM.004US0

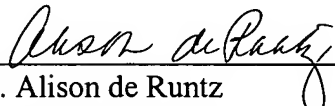
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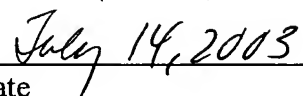
Serial No.: 10/074,757

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A check is enclosed that includes the amount of \$930.00, as set forth in the enclosed transmittal letter.

Respectfully submitted,


K. Alison de Runtz
Attorney of Record
Reg. No. 37,119


Date

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